

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	27	(micro near (machine or machining or machined)) and wavelength and (micro near (optical)) and laser and (align or aligned or alignment) and pixel and ((sub near micron) or submicron)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/05 10:34
L2	25	(micro near (machine or machining or machined)) and wavelength and (micro near (optical)) and laser and (align or aligned or alignment) and camera and ((sub near micron) or submicron)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/05 10:34
L3	13	(micro near (machine or machining or machined)) and wavelength and (micro near (optical)) and laser and (align or aligned or alignment) and (digital near camera) and ((sub near micron) or submicron)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/05 10:34